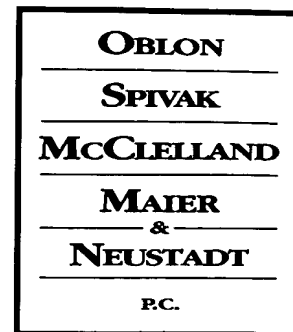


Docket No.: 214814US0

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231



ATTORNEYS AT LAW

RE: Application Serial No.: 09/975,262
Applicants: Naomichi MIYAKAWA
Filing Date: October 12, 2001
For: METHOD FOR PRODUCING A SILICON NITRIDE
FILTER
Group Art Unit: 1731
Examiner: FIORILLA

RECEIVED
DEC 24 2003
TC 1700 MAIL ROOM

SIR:

Attached hereto for filing are the following papers:

Amendment + Marked-Up Copy; In re Antonie, 195 USPQ 6

Our check in the amount of \$0.00 is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.


Norman F. Oblon

Registration No. 24,618



22850

(703) 413-3000 (phone)
(703) 413-2220 (fax)

Samuel H. Blech
Registration No. 32,082